



First Named Inventor	Chun Chen	INFORMATION DISCLOSURE STATEMENT
Serial No.	10/602,324	
Filing Date	June 24, 2003	
Group Art Unit	2818	
Examiner Name	Unknown	
Confirmation No.	1950	
Attorney Docket No.	400.211US01	
Title: SELF-ALIGNED SILICIDE FOR WORD LINES AND CONTACTS		

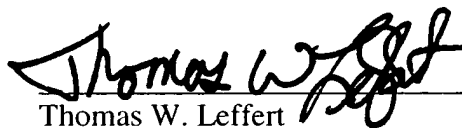
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In compliance with 37 C.F.R. §§ 1.56 and 1.97, *et seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified Application. Applicant respectfully requests that this Information Disclosure Statement be entered and the references listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to MPEP §609, Applicant further requests that the Examiner initial next to each reference on the Form 1449 to indicate that the listed references have been considered. Applicant further requests that a copy of the initialed Form 1449 be returned with the next official communication.

As an Office Action has not yet issued in this application, Applicant believes that no fees are due. However, the Commission for Patents is hereby authorized to charge any additional fees to Deposit Account No. 501373. If the Examiner has any questions or concerns regarding this application, please contact the undersigned at the number listed below.

Respectfully submitted,

Date: 29 OCT 03



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U.S. Patent References				
Examiner Initials	Document No.	Issue/Published Date	Name	Filing Date
	5,770,507	June 23, 1998	Chen et al.	Jan. 21, 1997
	6,194,279	Feb. 27, 2001	Chen et al.	June 28, 1999
	6,204,129	March 20, 2001	Hwang et al.	Oct. 22, 1999
	6,207,492	March 27, 2001	Tzeng et al.	June 5, 2000
	6,245,626	June 12, 2001	Chen et al.	July 7, 1999
	6,291,354	Sep. 18, 2001	Hsiao et al.	May 21, 1999
	6,559,044	May 6, 2003	Chen et al.	Sept. 10, 2002
	6,617,215	Sept. 9, 2003	Halliyal et al.	March 27, 2002

Foreign Patent References					
Examiner Initials	Foreign Patent		Name	Publication Date	T?
	Country	No.			

Other References	
Examiner Initials	Author, Title, Date, Pages, etc.

Examiner Signature		Date Considered	
*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			